

Notice of References CitedApplication No.
08/807,737Applicant(s)
Ohtani et al.Examiner
Martin SulskyGroup Art Unit
2813

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U.S. PATENT DOCUMENTS

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
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FOREIGN PATENT DOCUMENTS

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V	Sorab K. Gandhi, VLSI Fabrication Principles, second edition, p 484,485,533-535	1994
W	John L. Vossen and Werner Kern, Thin Film Processes II, 537-541	1991
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